

**Notice of References Cited**Application/Control No.  
09/595,583Applicant(s)/Patent Under  
Reexamination  
MIZE ET AL.Examiner  
Yelena G. Gakh, Ph.D.Art Unit  
1743

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	C	US-			
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	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Udler et al. "Tungsten-Titanium Sputtering Target Technology", Advanced Materials Division, Technial Note 203, 1994
	V	<a href="http://www.iamaterials.com/sputter/targets.htm">http://www.iamaterials.com/sputter/targets.htm</a> , International Advanced Materials, 1999
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.